

<b>Notice of References Cited</b>	Application/Control No. 10/622,688	Applicant(s)/Patent Under Reexamination KIDA ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-2001/0015786 a1	08-2001	Katsura, Hideki	349/153
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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